

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8

hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, with sufficient postage, in an envelope addressed to: Commissioner for Patents, P. O. Box 1350, Alexandria, VA 22313-1450,

on the below date: Name: Anthony P. Curtis, Ph.D., 46,193 Signature:

BRINKS HOFER GILSON &LIONE

IN THE UNITED STATES PATENT AND TR	ADEMARK OFFICE
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In re Appln. of: Kenichi Mitsumori et al.

Appln. No.:

10/801,476

Filed:

March 16, 2004

For:

Ultrasonic Vibrator Wet-Treatment Nozzle,

and Wet-Treatment Apparauts

Attorney Docket No:

9281/4823

Mail Stop Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

TRANSMITTAL

Art Unit: 1746

Examiner: Not yet assigned

Sir:

 \boxtimes

Attac	hed is/are:
\boxtimes	Transmittal Cover Letter (1p. Filed in Dup.); Information Disclosure Statement and PTO Form 1449 (3pp.);
\boxtimes	Return Receipt Postcard
Fee c	alculation:
\boxtimes	No additional fee is required.
	Small Entity.
	An extension fee in an amount of \$ for amonth extension of time under 37 C.F.R. § 1.136(a).
	A petition or processing fee in an amount of \$ under 37 C.F.R. § 1.17().
	An additional filing fee has been calculated as shown below:

					Sma	II Entity		Not a S	mall Entity
	Claims Remaining After Amendment		Highest No. Previously Paid For	Present Extra	Rate	Add'l Fee	or	Rate	Add'l Fee
Total		Minus			x \$25=			x \$50=	
Indep.		Minus			x 100=			x \$200=	
First Pre	esentation of Multiple D	ep. Claim	<u> </u>		+\$180=			+ \$360=	
					Total	\$		Total	\$

Fee	payment:
	A check in the amount of \$ is enclosed.
	Please charge Deposit Account No. 23-1925 in the amount of \$. A copy of this Transmittal is enclosed for this purpose.
	Payment by credit card in the amount of \$ (Form PTO-2038 is attached).

The Director is hereby authorized to charge payment of any additional filing fees required under 37 CFR § 1.16 and any patent application processing fees under 37 CFR § 1.17 associated with this paper (including any extension fee required to ensure that this paper is timely filed), or to credit any overpayment, to Deposit Account No. 23-1925.

Curtis, Ph.D. (Reg. No. 46,193)

The PTO did not receive the listed Items(s)

Respectfully submitted.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Appln. of: Kenichi Mitsumori ET AL.

Appln. No.: 10/801,476

Filed: March 16, 2004

For: ULTRASONIC VIBRATOR,

WET-TREATMENT NOZZLE,

AND WET-TREATMENT

APPARATUS

Attorney Docket No: 9281-4823

Examiner: Not yet assigned

Art Unit: 1746

INFORMATION DISCLOSURE STATEMENT

In accordance with the duty of disclosure under 37 C.F.R. §1.56 and §§1.97-1.98, and more particularly in accordance with 37 C.F.R. §1.97(b), Applicants hereby cite the following reference(s):

Date of Publication 07/2003	Patentee/Applicant/Assignee
07/2003	
0112000	Shimogawa et al.
09/1999	Rorick, Timpothy P.
04/1997	Shibano
08/1996	Kaida, Hiroaki
04/1995	Henriquez et al.
04/1993	Shibata, Hajime
08/1991	Bran, Mario E.
07/1989	Mattiussi, Al
03/1989	Murao et al.
07/1988	EerNisse et al.
10/1982	Kawashima et al.
08/1978	Olson et al.
05/1976	Lierke, Ernst-Gunther
04/1973	Tysk, Jan Erik
08/1969	Noon Alonzo W
03/1969	Scarpa Thomas J
12/1967	Straube Helmut J
05/1967	Scarpa Thomas J
12/1955	Reimar Benioff
09/1946	Hugo Benioff
FOREIGN PATENT DO	CUMENTS
DATE	COUNTRY
03/1996	Japan
ART - NON PATENT LITE	RATURE DOCUMENTS
	07/1989 03/1989 07/1988 10/1982 08/1978 05/1976 04/1973 08/1969 03/1969 12/1967 05/1967 12/1955 09/1946 FOREIGN PATENT DC DATE 03/1996

"Advanced Wet Cleaning Using Novel Nozzle and Functional Ultrapure Water in Next Generation FPD/LSI Manufacturing;" Ken-ichi Mitsumori et al; The Ninth International Symposium on Semiconductor Manufacturing; Tokyo, Japan Applicants are enclosing Form PTO-1449 (one sheet), along with a copy of each listed reference for which a copy is required under 37 C.F.R. §1.98(a)(2). As each of the listed references is in English, no further commentary is believed to be necessary, 37 C.F.R §1.98(a)(3). Applicants respectfully request the Examiner's consideration of the above reference(s) and entry thereof into the record of this application.

This application is a divisional application of U.S. Serial No. 09/946,113, filed September 4, 2001 and is relied upon for an earlier filing dated under 35 U.S.C. § 120. In accordance with Rule 37 C.F.R. § 1.98(d) no copies of documents are being submitted since all of the documents were previously cited and submitted to the Patent and Trademark Office in the prior application.

By submitting this Statement, Applicants are attempting to fully comply with the duty of candor and good faith mandated by 37 C.F.R. §1.56. As such, this Statement is not intended to constitute an admission that any of the enclosed references, or other information referred to therein, constitutes "prior art" or is otherwise "material to patentability," as that phrase is defined in 37 C.F.R. §1.56(a).

Applicants have calculated no fee to be due in connection with the filing of this Statement. However, the Director is authorized to charge any fee deficiency associated with the filing of this Statement to a deposit account, as authorized in the Transmittal accompanying this Statement.

Respectfully submitted,

Anthony P.) Curtis, Ph.D.

Registration No. 46,193

FORM PTO-1449	SERIAL NO.	CASE NO.
With a sale	10/801,476	9281-4823
LIST OF PATENTS AND PUBLICATIONS FOR	FILING DATE	GROUP ART UNIT
APPLICANT'S INFORMATION DISCLOSURE	March 16, 2004	1746
STATEMENT		
(use several sheets if necessary)	APPLICANT(S): Kenichi Mitsum	ori et al.

REFERENCE DESIGNATION	SNI II	e n	ATENT
REFERENCE DESIGNATION	JN U.	5 P	AIENI

EXAMINER INITIAL		DOCUMENT NUMBER Number-Kind Code (if known)	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
	A20	6,584,660	07/2003	Shimogawa et al.		
	A19	5,956,293	09/1999	Rorick, Timpothy P.		
	A1	5,617,887	04/1997	Shibano		
	A18	5,548,180	08/1996	Kaida, Hiroaki		
	A17	5,406,531	04/1995	Henriquez et al.		
	A16	5,203,362	04/1993	Shibata, Hajime		
	A15	5,037,481	08/1991	Bran, Mario E.		
•	A14	4,850,378	07/1989	Mattiussi, Al		
•	A2	4,811,748	03/1989	Murao et al.		
	A3	4,754,646	07/1988	EerNisse et al.		
	A4	4,355,257	10/1982	Kawashima et al.		
	A5	4,109,863	08/1978	Olson et al.		
	A6	3,955,880	05/1976	Lierke, Ernst-Gunther		
	A7	3,729,138	04/1973	Tysk, Jan Erik		
	A8	3,461,843	08/1969	Noon Alonzo W		
	A9	3,433,461	03/1969	Scarpa Thomas J		
	A10	3,360,664	12/1967	Straube Helmut J		
	A11	3,321,189	05/1967	Scarpa Thomas J		Marco
	A12	2,728,869	12/1955	Reimar Benioff		
	A13	2,406,792	09/1946	Hugo Benioff		

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER Number-Kind Code (if known)	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION YES OR NO
	A21	8-57435	03/1996	Japan		
						-

EXAMINER		OTHER ART – NON PATENT LITERATURE DOCUMENTS					
INITIAL	(Ir	(Include name of author, title of the article (when appropriate), title of the item (book, magazine, journal, serial,					
	sym	posium, catalog, etc.), date page(s), volume-issue number(s), publisher, city and/or country where published.					
	A22	"Advanced Wet Cleaning Using Novel Nozzle and Functional Ultrapure Water in Next					
		Generation FPD/LSI Manufacturing;" Ken-ichi Mitsumori et al; The Ninth International					
		Symposium on Semiconductor Manufacturing; Tokyo, Japan					

EXAMINER	DATE CONCIDEDED	
LEVAMINEK	DATE CONSIDERED	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.